

03560.002732.



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

|                               |   |                        |
|-------------------------------|---|------------------------|
| In re Application of:         | ) |                        |
|                               | : | Examiner: K. Fernandez |
| Masato MURAKI et al.          | ) |                        |
|                               | : | Group Art Unit: 2881   |
| Application No.: 09/708,590   | ) |                        |
|                               | : | Confirmation No.: 2106 |
| Filed: November 9, 2000       | ) |                        |
|                               | : |                        |
| For: CORRECTING METHOD FOR    | ) |                        |
| CORRECTING EXPOSURE DATA USED | : | March 2, 2004          |
| FOR A CHARGED PARTICLE BEAM   | ) |                        |
| EXPOSURE SYSTEM               | : |                        |

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**Mail Stop Non-Fee Amendment**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Official Action dated December 2, 2003, please amend the above-identified application as follows: